



00862.022205.

*IFW*  
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yoshiyuki NAGAI et al.

Application No.: 09/839,139

Filed: April 23, 2001

For: LASER OSCILLATION APPARATUS, EXPOSURE  
APPARATUS, SEMICONDUCTOR DEVICE  
MANUFACTURING METHOD, SEMICONDUCTOR ) March 7, 2005  
MANUFACTURING FACTORY, AND EXPOSURE :  
APPARATUS MAINTENANCE METHOD )

**Mail Stop Issue Fee**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THIRD REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

Sir:

In response to the Corrected Filing Receipt mailed January 18, 2005, Applicants' attorneys request that another corrected Official Filing Receipt be issued in the above-identified application to make the following correction. The Corrected Filing Receipt dated January 18, 2005, omits the Assignee information. Specification, under the section entitled "**Applicant(s)**," please insert the following:

**-- Assignment For Published Application**

Canon Kabushiki Kaisha, Tokyo, JAPAN --.

A copy of the Official Filing Receipt with the requested correction indicated in red is attached.

Applicants, therefore, request issuance of a corrected Official Filing Receipt corrected as shown above.

Applicants believe that no fees should be incurred in filing this paper. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fees be deemed necessary for filing this paper. A duplicate of this paper is attached for that purpose.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address listed below.

Respectfully submitted,

  
\_\_\_\_\_  
Attorney for Applicants  
Steven E. Warner  
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APPARATUS MAINTENANCE METHOD

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: Examiner: M. Landau  
)  
: Group Art Unit: 2815  
)  
: Confirmation No.: 1616  
)  
: Issue Fee Paid: August 30, 2004  
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: March 7, 2005  
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Alexandria, VA 22313-1450

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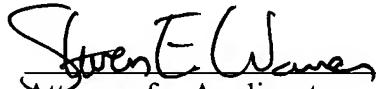
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## UNITED STATES PATENT AND TRADEMARK OFFICE

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
09/839,139	04/23/2001	2815	2154	862.C2205	11	24	6

SEW

CONFIRMATION NO. 1616

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FITZPATRICK CELLA HARPER & SCINTO  
30 ROCKEFELLER PLAZA  
NEW YORK, NY 10112

00862.022205 CORRECTED FILING RECEIPT



OC000000014974607

Date Mailed: 01/18/2005

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

Yoshiyuki Nagai, Tochigi, JAPAN;  
Naoto Sano, Tochigi, JAPAN;

Assignment For Published Patent Application  
canon Kabushiki Kaisha, Tokyo, JAPAN

Power of Attorney: The patent practitioners associated with Customer Number 05514.

## Domestic Priority data as claimed by applicant

## Foreign Applications

JAPAN 2000-126502 04/26/2000

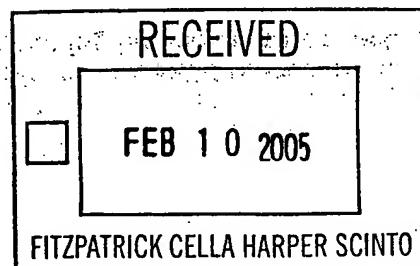
If Required, Foreign Filing License Granted: 06/13/2001

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US09/839,139**

Projected Publication Date: Not Applicable

Non-Publication Request: No

Early Publication Request: No



**Title**

LASER OSCILLATION APPARATUS, EXPOSURE APPARATUS, SEMICONDUCTOR DEVICE MANUFACTURING METHOD, SEMICONDUCTOR MANUFACTURING FACTORY, AND EXPOSURE APPARATUS MAINTENANCE METHOD

**Preliminary Class**

372

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Title 35, United States Code, Section 184  
Title 37, Code of Federal Regulations, 5.11 & 5.15**

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